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Application No.: 10/800,516

Case No.: 53949US013

**LISTING OF CLAIMS:**

The following list of claims will replace all prior versions of claims in the application:

1. (original) A conditioning disk comprising:  
a substrate having top and bottom surfaces;  
a plurality of abrasive particles arranged on at least a portion of said top substrate surface, said  
abrasive particles affixed to said substrate with a matrix material; and  
a carrier affixed to said bottom substrate surface,  
wherein said carrier comprises at least one of synthetic plastic or ceramic.
2. (original) The conditioning disk of claim 1 wherein said abrasive particles comprise  
at least one of aluminum oxide, cubic boron nitride, or diamond.
3. (original) The conditioning disk of claims 1 wherein said matrix material comprises at  
least one of aluminum, boron, carbon, chromium, tungsten, cobalt, titanium, zinc, iron,  
manganese, or silicon.
4. (original) The conditioning disk of claims 1 further comprising a corrosion resistant  
powder.
5. (original) The conditioning disk of claim 1 wherein said substrate is formed of said  
matrix material.
6. (original) The conditioning disk of claim 1 wherein said substrate is more flexible than  
said carrier.
7. (original) The conditioning disk of claim 1 wherein said carrier is affixed to said  
substrate with an adhesive.
8. (original) The conditioning disk of claim 1 wherein said abrasive particles are arranged  
in a predetermined pattern.

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9. (original) The conditioning disk of claim 1 wherein said matrix material comprises a brazing alloy.
10. (original) The conditioning disk of claim 9 wherein said abrasive particles are diamond and said brazing alloy comprises at least one of chromium, tungsten, cobalt, titanium, zinc, iron, manganese, or silicon.
11. (original) The conditioning disk of claim 9 wherein said abrasive particles are cubic boron nitride and said brazing alloy comprises at least one of aluminum, boron, carbon, or silicon.
12. (original) The conditioning disk of claim 9 wherein said abrasive particles are aluminum oxide and said brazing alloy comprises at least one of aluminum, boron, carbon, or silicon.
13. (withdrawn) A conditioning disk comprising:  
a substrate having top and bottom surfaces;  
a plurality of abrasive particles arranged on at least a portion of said top substrate surface, said abrasive particles affixed to said substrate with a matrix material; and  
a polycarbonate carrier affixed to said bottom substrate surface.
14. (withdrawn) The conditioning disk of claim 13 wherein said abrasive particles comprise at least one of aluminum oxide, cubic boron nitride, or diamond.
15. (withdrawn) The conditioning disk of claims 13 wherein said matrix material comprises at least one of aluminum, boron, carbon, chromium, tungsten, cobalt, titanium, zinc, iron, manganese, or silicon.

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16. (withdrawn) The conditioning disk of claim 13 further comprising a corrosion resistant powder.
17. (withdrawn) The conditioning disk of claim 13 wherein said carrier is affixed to said substrate with an adhesive.
18. (withdrawn) The conditioning disk of claim 13 wherein said abrasive particles are arranged in a predetermined pattern.
19. (withdrawn) The conditioning disk of claim 13 wherein said matrix material comprises a brazing alloy.
20. (withdrawn) The conditioning disk of claim 19 wherein said abrasive particles are diamond and said brazing alloy comprises at least one of chromium, tungsten, cobalt, titanium, zinc, iron, manganese, or silicon.
21. (withdrawn) The conditioning disk of claim 19 wherein said abrasive particles are cubic boron nitride and said brazing alloy comprises at least one of aluminum, boron, carbon, or silicon.
22. (withdrawn) The conditioning disk of claim 19 wherein said abrasive particles are aluminum oxide and said brazing alloy comprises at least one of aluminum, boron, carbon, or silicon.
23. (original) A conditioning disk comprising:  
a substrate having top and bottom surfaces;  
a plurality of abrasive particles arranged on at least a portion of said top substrate surface, said abrasive particles affixed to said substrate with an electroplated metal; and  
a carrier affixed to said bottom substrate surface,  
wherein said carrier comprises at least one of synthetic plastic or ceramic.

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24. (withdrawn) The conditioning disk of claim 23 wherein said carrier comprises polycarbonate.
25. (original) The conditioning disk of claim 23 wherein said abrasive particles comprise at least one of aluminum oxide, cubic boron nitride, or diamond.
26. (original) The conditioning disk of claim 23 wherein said electroplated metal comprises nickel.
27. (original) The conditioning disk of claim 26 wherein said abrasive particles are diamond.
28. (original) The conditioning disk of claim 23 wherein said substrate is formed of said electroplated metal.
29. (original) The conditioning disk of claim 23 wherein said carrier is affixed to said substrate with an adhesive.
30. (original) The conditioning disk of claim 23 wherein said abrasive particles are arranged in a predetermined pattern.